

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Jurgensen et al.

### Group Art Unit:

Serial No.:

Filed:

Attorney Docket No: 98-058/ID

For: Confinement Device for Use in Dry Etching of Substrate Surface and Method of Dry Etching a Wafer Surface

## **PRELIMINARY AMENDMENT**

Hon. Commissioner of Patents and Trademarks  
Washington, D.C. 20231

Dear Sir:

Prior to examination, please amend the application as follows:

**IN THE CLAIMS**

Please cancel claims 1-21.

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REMARKS

The Applicants filed the present application with claims 1-33. By this Preliminary Amendment, the Applicant cancelled claims 1-21. Thus, claims 21-33 remain pending.

It is believed that all claims in the subject application are now in condition for immediate allowance, and such action is respectfully requested. If it is felt for any reason that direct communication with the Applicant's attorney would serve to advance prosecution of this case to finality, the Examiner is invited to call the undersigned Peter P. Scott at the telephone number below.

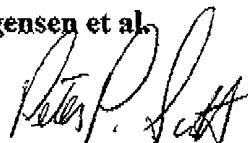
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**AUTHORIZATION TO PAY AND PETITION  
FOR THE ACCEPTANCE OF ANY NECESSARY FEES**

If any charges or fees must be paid in connection with this communication (including but not limited to the payment of an extension fee or issue fees), or if any overpayment is to be refunded in connection with the present application, any such charges or fee, or any such overpayment may be respectively paid out of, or into, the Deposit Account No. 12-2252 of LSI Logic Corporation. If any such payment also requires a Petition or Extension Request, please construe this authorization as the required Petition or Request.

Respectfully submitted,

Jurgensen et al.



By: Peter P. Scott  
Attorney for Applicant  
Reg. No. 33,279

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